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CONFIRMATION NO. 1896

SERIAL NUMBER 10/805,890	FILING DATE 03/22/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 7017 C1/ETCH/METAL-NVM/JB
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APPLICANTS

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** CONTINUING DATA *****

This application is a CON of 10/092,795 03/06/2002 PAT 6,806,095

~~Hee~~ BT

** FOREIGN APPLICATIONS *****

None BT

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 05/31/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <u>Blinh Tran</u> Initials	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 4
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ADDRESS

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TITLE

Method of plasma etching of high-K dielectric materials with high selectivity to underlying layers

FILING FEE

FEES: Authority has been given in Paper
 No. _____ to charge/credit DEPOSIT ACCOUNT

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)